



[10191/1808]

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor(s) : Franz LAERMER et al.  
Serial No. : 09/889,838  
Filed : January 24, 2002  
For : PLASMA ETCHING METHOD HAVING PULSED  
SUBSTRATE ELECTRODE POWER  
Examiner : Allan Olsen  
Art Unit : 1763  
Confirmation No. : 1541

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on:

Date: December 1, 2003 Reg. No. 22,490

Signature: Richard L. Mayer  
Richard L. Mayer

*Resub  
42,194*

**AMENDMENT**

S I R:

In response to the Office Action of July 30, 2003, kindly amend the above-captioned application as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.

12/08/2003 MBELETE1 00000040 110600 09889838

01 FC:1201 86.00 DA  
02 FC:1202 342.00 DA